

**SUPPORTING STATEMENT FOR  
EPA INFORMATION COLLECTION REQUEST NUMBER 1823.03  
REPORTING AND RECORD KEEPING REQUIREMENTS UNDER THE  
PFC REDUCTION/CLIMATE PARTNERSHIP FOR THE  
SEMICONDUCTOR INDUSTRY**

**March 11, 2008**

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## **1. IDENTIFICATION OF THE INFORMATION COLLECTION**

### **1(a) Title of the Information Collection**

This ICR is entitled "Reporting and Recordkeeping Requirements under the Perfluorocompound (PFC) Reduction/Climate Partnership for the Semiconductor Industry," EPA ICR number 1823.03.

### **1(b) Short Characterization**

On February 14, 2002, President Bush announced a goal to reduce U.S. greenhouse gas (GHG) emissions intensity – the ratio of emissions to economic output by American industry – by 18 percent over the next 10 years without sacrificing economic growth. Achieving this aim will require a combination of short-, medium-, and long-term actions. Initially, the Administration has adopted policies to encourage industry to take voluntary actions using available, cost-effective technologies and best practices to reduce GHG emissions intensity. EPA's PFC Reduction/Climate Partnership for the Semiconductor Industry is an important program contributing to the overall reduction in greenhouse gas emissions from projected 2010 levels. The semiconductor industry partnership, along with EPA's Energy Star programs and the Voluntary Aluminum Industrial Partnership (VAIP) are voluntary initiatives seeking to reduce greenhouse gas emissions using a pollution prevention approach.

The PFC Reduction/Climate Partnership for the Semiconductor Industry is a voluntary program that promotes reduction of fluorinated compound (FC)<sup>1</sup> greenhouse gas emissions including perfluoromethane (CF<sub>4</sub>), perfluoroethane (C<sub>2</sub>F<sub>6</sub>), sulfur hexafluoride (SF<sub>6</sub>), nitrogen trifluoride (NF<sub>3</sub>), and perfluoropropane (C<sub>3</sub>F<sub>8</sub>), from semiconductor manufacturing. A single hydrofluorocarbon, trifluoromethane (CHF<sub>3</sub>) is included in the program with the PFCs due to its high global warming potential. EPA's semiconductor industry partners have committed to reduce their PFC emissions 10 percent below their 1995 baseline level and support the President's Climate VISION initiative. As a partner to the industry, EPA serves as a clearinghouse of technical information on successful strategies for reducing PFC emissions that are economically, technically, and environmentally sound. EPA also helps assess the global warming potential of potential substitute chemicals and publicly recognizes the partner companies' achievements.

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<sup>1</sup> FCs are the most potent greenhouse gases known. In comparison to an equivalent amount of the common greenhouse gas carbon dioxide, PFCs are 6,000 - 24,000 times more potent. Also, the atmospheric lifetimes of the PFCs range from 2,600 to 50,000 years.

Participation in the program begins with completion of a Memorandum of Understanding (MOU) that outlines responsibilities of the PFC Reduction/Climate Partnership. This MOU reflects a voluntary agreement between a semiconductor manufacturer (the Partner Company) and EPA (collectively, the Parties). By joining the Partnership, a Company agrees to submit a Company-specific annual report, identifying an overall estimate of PFC emissions by gas, to a third party designated by the participating Companies. The MOU also specifies that the Partner Company will direct the designated third party to create a confidential data depository for the information supplied by the Partner Company. In addition, the MOU states that the Partner Company will direct the designated third party to prepare an industry-wide annual report, to be submitted to EPA, that aggregates PFC emissions estimates, and provides each Partner Company's annual emissions by gas on a "blind" or anonymous basis. The Partner Company also agrees that it will share with the EPA and others in the semiconductor industry information about successful PFC emission reduction processes and technologies that the Partner Company considers nonconfidential. This agreement applies only to PFC emissions originating from U.S. semiconductor manufacturing sites and can be terminated by either Party 30 days after the receipt of written notice by the other Party with no penalties or continuing obligations.

## **2. NEED FOR AND USE OF THE INFORMATION COLLECTION**

### **2(a) Need and Authority for the Collection**

President Bush launched the Climate VISION initiative in February 2003 as part of his plan to reduce the national greenhouse gas intensity (the amount of greenhouse gases emitted per dollar of GDP) by 18 percent over 10 years. EPA's semiconductor industry partners are contributing to the Climate VISION's efforts to reduce U.S. greenhouse gas emissions by striving to reduce their absolute PFC emissions 10 percent below their 1995 baseline level (see [www.climatevision.gov/sectors/semiconductors](http://www.climatevision.gov/sectors/semiconductors)). The PFC Emission Reduction Partnership also supports EPA's pollution prevention goals. Authority for collection of this information is provided in Sections 7403(a)(1), (b)(6), and (g)(1) [Clean Air Act §103].

EPA has developed this ICR to obtain authorization to collect information from Companies participating in the PFC Reduction/Climate Partnership for the Semiconductor Industry. By participating in the program, a Partner Company voluntarily agrees to the terms of various information collections specified by EPA in the Memorandum of Understanding (MOU). The Partner Company submits the MOU to EPA. In addition, the Partner Company should submit to a designated third party a Company-specific annual report that includes an overall estimate of the Partner Company's PFC emissions by gas type.

An industry-designated third party aggregates information on Company-specific PFC emissions into an industry-wide annual report, and combined with information on Partner Companies' PFC emissions (submitted on a blind basis), EPA is able to evaluate the overall PFC

emission reductions achieved by the voluntary program. The MOU's information-sharing provision allows EPA to collect and share information about successful PFC emission reduction processes and technologies that Partner Companies consider nonconfidential.

## **2(b) Practical Utility and Users of the Data**

The Agency has used the MOU to establish a framework for a voluntary agreement with Companies in the Partnership. EPA will use information submitted in the industry-wide annual reports to demonstrate that Partner Companies are reducing PFC emissions from semiconductor manufacturing operations. EPA also will use the information on an annual basis to develop the Inventory of U.S. Greenhouse Gas Emissions and Sinks. The U.S. government committed to developing and maintaining the Inventory under the United Nations Framework Convention on Climate Change (UNFCCC). In addition, EPA will use the information collected to evaluate the quantity of emissions prevented and to publicize Company and Partnership successes. EPA may also use aggregated data to disseminate information concerning the Partnership. It is expected that the industry will employ this information to understand the extent and rate of growth of its PFC emissions in the U.S. To further this process, information sharing provided by Partner Companies will be used by EPA to publicize new processes or technologies that reduce emissions, and by the Partner Companies themselves to improve their environmental performance.

## **2(c) Assessment of Partnership's Achievements**

In 2001, OMB requested EPA to evaluate the extent to which the Partner Companies would have reduced their PFC emissions in the absence of the Partnership. EPA constructed a top-down vintage model to better understand the industry's diverse and dynamic manufacturing technologies and estimate the U.S. industry's "business as usual" (BAU) PFC emissions.

When estimating air emissions from any source, it is customary practice to express the emissions as a product of two factors: an emissions factor, expressed as emissions per unit of activity and an activity factor, expressed in this case as a quantity of silicon consumed during semiconductor manufacture. EPA's PFC Emissions Vintage Model (PEVM) derives its PFC emissions factor from the Partners' annual reports and U.S. silicon consumption is derived from reports and projections provided by VLSI Research ([www.vlsiresearch.com](http://www.vlsiresearch.com)).

Figure 1 near the end of this document depicts the Partners' actual PFC emissions through 2003 as compared to expected BAU emissions. Figure 1 also presents the estimated reduction of the partners' BAU emissions attributable to the advent and adoption of copper interconnects. A full description of EPA's PEVM used to estimate BAU emissions with and without copper interconnects is available at <http://epa.gov/semiconductor-pfc/resources.html>.

Copper interconnect technology evolved since the inception of the partnership in 1996 and was designed primarily to enable faster and smaller products. The smaller less resistive interconnects have also delivered the added benefit of reducing the number of PFC emitting process steps. EPA has determined that the copper interconnect is the only new manufacturing technology developed to date without the Partnership's influence that reduces the semiconductor industry's PFC emissions intensity.

The Partner Companies have identified and are implementing several other new manufacturing technologies and process improvements aimed at significantly improving their environmental performance. In response to EPA's voluntary initiative, the Partner Companies and their material suppliers have developed new production technologies including:

- remote  $\text{NF}_3$  plasma cleaning for chemical vapor deposition (CVD) chambers,
- process optimizations,
- alternative chemicals, and
- advanced PFC emissions abatement devices.

Remote  $\text{NF}_3$  chamber cleaning reduces PFC emissions by greater than 99 percent as compared to the traditional  $\text{C}_2\text{F}_6$  cleaning process. This technology is now found on all new CVD equipment sold in the U.S. and is being retrofitted to existing equipment by some Partner Companies.

In addition, Partner Companies have revisited their established manufacturing processes and successfully adjusted their production process "recipes" (i.e., parameters such as the PFC gas flow rates, plasma power, and pressure) to reduce PFC use. The Partners have also improved the equipment's ability to detect the process endpoint and thus ensure PFC gas flow delivery only when necessary. These types of process optimizations have reduced PFC emissions and in some cases improved throughput thereby delivering the added benefit of increased productivity.

EPA's Semiconductor Partnership and its aggressive PFC emission reduction goal have sent a clear message to the industry's equipment and chemical suppliers. The industry's suppliers are responding by designing new chemicals with lower global warming impact and improved abatement devices that can neutralize PFC emissions before being exhausted to the atmosphere. For example, prior to the Partnership, the industry's abatement devices were designed to control regulated criteria pollutants but these devices would not destroy the very stable and non-reactive PFC gases. Today, equipment suppliers offer a menu of abatement options capable of controlling regulated pollutants and PFC emissions in one device. Many Partner Companies are choosing to upgrade their abatement systems to address PFC emissions and most new fabrication facilities are completely outfitted with the cleaner advanced technologies.

### 3. NONDUPLICATION, CONSULTATIONS, AND OTHER COLLECTION CRITERIA

#### 3(a) Nonduplication

The information to be obtained under this ICR is not collected by any other EPA program or Federal agency. The PFCs are not currently regulated chemicals, and the emissions of the gases are not tracked elsewhere. No databases are otherwise available for obtaining this information.

#### 3(b) Public Notice Request Prior to ICR Submission to OMB

In compliance with the Paperwork Reduction Act of 1995, EPA issued a public notice in the Federal Register [XXX, 2008 Vol. XX, Number 162, Page 51831-51832] soliciting public comments for a 60-day period ending October XXXX, 2008. EPA received no public comments on the ICR during the comment period.

#### 3(c) Consultations

In the fall of 2000, EPA consulted with eight Companies in the PFC Reduction/Climate Partnership to obtain feedback on the burdens and costs associated with the Partnership's paperwork activities. EPA tried to ensure that the Partner Companies contacted were representative of Companies across the Partnership. After collecting their feedback, EPA developed an average burden and cost estimate for each respondent activity in this ICR and incorporated these estimates into the ICR's burden and cost calculations. The Partnership's composition and responsibilities have not changed significantly since 2000. Therefore, EPA has not adjusted the burden estimates for the partnership's activities. EPA has updated the compensation level for the labor categories using U.S. Department of Labor's Bureau of Labor Statistics information. See Section 6 of this ICR for these calculations.

EPA consulted with the following Partner Companies:

NAME OF CONTACT	NAME OF ORGANIZATION	PHONE NUMBER
Jim Jewett	Intel	(480) 554-3621
Joe Mauser	Philips	(505) 822-7634
Coleen Miller & Tina Gilliland	Texas Instruments	(512) 356-7430
Mishelle Noble	Dominion Semiconductor	(703) 396-1120



Jamie Rubin	Agilent Technologies	(970) 288-4880
David Sovie	Eastman Kodak	(716) 722-9124
Tom Tamayo	International Business Machines	(802) 769-4950
Diane Van Schoten	Advanced Micro Devices	(408) 749-2045

### **3(d) Effects of Less Frequent Collection**

EPA requests that the Partner Company submit information on its PFC emissions to the designated third party once per year. The designated third party will submit an industry-wide annual report to EPA once per year. EPA believes that any reduction in the frequency of this information collection would impede efforts by EPA to evaluate results of this program. In particular, if information were submitted less than once per year, emission inventories of greenhouse gases prepared by the government on an annual basis would suffer because the information used in such inventories would be dated. A less frequent collection would not enable EPA to track annual greenhouse gas emission reductions for the Climate VISION initiative or to submit an accurate assessment to the UNFCCC.

### **3(e) General Guidelines**

This ICR adheres to the guidelines stated in the Paperwork Reduction Act of 1995, OMB's implementing regulations, OMB's Information Collection Review Handbook, and other applicable OMB guidance.

### **3(f) Confidentiality**

No confidential information will be submitted to EPA at any point in the information collection process. Information submitted to EPA in the industry-wide annual report will be either aggregated or provided on a "blind" basis. Further, data will be released by the designated third party only if a sufficient number of semiconductor companies participate in the Partnership so that aggregated emissions data cannot be correlated back to an individual Partner Company or a small group of Partner Companies. In addition, other information regarding successful PFC reduction strategies shared with EPA by the Partner Companies is nonconfidential.

**3(g) Sensitive Questions**

No questions of a sensitive nature or of matters usually considered private to individuals will be asked.

**4. THE RESPONDENTS AND THE INFORMATION REQUESTED**

**4(a) Respondents/SIC and NAICS Codes**

The following is the Standard Industrial Classification (SIC) code and the corresponding North American Industry Classification System (NAICS) code associated with industries most likely to be affected by the information collection requirements covered under this ICR:

SIC	NAICS
3674	334413

These SIC and NAICS codes refer to the industry respondents for the Partnership. These SIC and NAICS codes are applicable because the Companies in the Partnership are semiconductor manufacturing companies.

**4(b) Information Requested**

Companies participating in the PFC Reduction/Climate Partnership submit a Memorandum of Understanding (MOU) to the EPA. The Partner Companies also agree to submit to the designated third party a Company-specific annual report that provides an overall estimate of PFC emissions by individual gas type. The designated third party will submit to EPA an industry-wide annual report that provides an aggregated estimate of PFC emissions. EPA may review Company-specific annual reports on the premises of the designated third party, after the third party has removed Company-identifying information. In addition, by signing the MOU, Partner Companies agree to share information about successful PFC emission reduction processes with the EPA and others in the semiconductor industry. Each of these information collections is described separately below, along with the respective data items and respondent activities.

**Memorandum of Understanding**

A number of Partner Companies worked with EPA to prepare the MOU establishing the terms of participation in the PFC Reduction/Climate Partnership. After reviewing the MOU, each Company must sign and submit it to the Agency. There are currently 21 semiconductor manufacturers representing 80 percent of the U.S. industry participating in the partnership. All 21 companies have already reviewed and signed MOUs with EPA. EPA is not actively recruiting new partners so the MOU activities and associated burden estimates have been removed from this ICR renewal.

## **Company-specific Annual Report**

The Partner Company agrees that it will prepare a Company-specific annual report to be submitted to the designated third party. The partners agree to report an estimate of PFC emissions by specific gas type (e.g., perfluoromethane (CF<sub>4</sub>), perfluoroethane (C<sub>2</sub>F<sub>6</sub>), sulfur hexafluoride (SF<sub>6</sub>), nitrogen trifluoride (NF<sub>3</sub>), trifluoromethane (CHF<sub>3</sub>), and perfluoropropane (C<sub>3</sub>F<sub>8</sub>)). The partner's report may also include a written explanation of the methodology used to generate such estimates. The Partner Company must submit its Company-specific annual PFC emissions report to the designated third party by April 15 of each year for the previous year. Because emissions estimates have potential competitive significance, they will be maintained on a Company-specific confidential basis.

### **(i) Data items**

The Company-specific annual report must include the following information:

- The Partner Company name, name of a designated Partner Company representative, contact phone number, and fax number;
- Reporting period;
- Overall estimate of PFC emissions for all U.S. facilities operated by the Partner Company;
- Description of methodology used for calculating PFC emissions estimate. The following is to be included for the methodology elements:
  - Description of how PFC usage was determined;
  - Description of source of emissions factors and how they were applied;
  - Description of how reductions due to abatement or other reduction techniques were accounted for; and
  - An example calculation (optional).

### **(ii) Respondent activity**

- Partner Companies will complete and submit to the designated third party the Company-specific annual report for each calendar year the MOU is in effect (due April 15 of subsequent year).

## **Industry-wide Annual Reports**

The designated third party is responsible for maintaining the Company-specific annual reports and compiling them into an industry-wide annual report. The designated third party will create a confidential data depository containing the annual reports supplied by the Partner

Companies. The designated third party will provide to EPA an industry-wide annual report. This report will be in the form of a letter to EPA. Based on the Company-specific annual reports, the designated third party will provide an aggregated, partnership report estimating PFC emissions by gas.

The third party will make available to EPA emissions estimates prepared by the Partner Companies and the written explanation of the methodology used. This information will be reviewed by EPA on the designated third party's premises. The designated third party will remove Company-identifying information from such documents before they are reviewed by EPA.

(i) Data items

The confidential data depository will include the following information:

- The Partner Company name, name of a designated Partner Company representative, contact phone number, and fax number;
- Reporting period;
- Overall estimate of PFC emissions for all U.S. facilities operated by the Partner Company,
- Description of methodology used for calculating PFC emissions estimates.

The industry-wide annual report prepared by the designated third party will include the following information:

- Reporting period;
- Total number of participating semiconductor manufacturers; and
- Total PFC emissions estimate for the semiconductor industry partnership.

(ii) Respondent activities

In developing and submitting this information, the designated third party will perform the following activities:

- Develop and update confidential data depository;
- Receive Company-specific annual reports and enter into confidential data depository;
- Complete and submit to EPA the industry-wide annual report containing an aggregated PFC emissions estimate;
- File and maintain copies of annual reports; and
- Make emissions estimates and written explanations of the methodology prepared by Partner Companies available to EPA for review.

## **Information Sharing**

Each Partner Company agrees that it will share with EPA and others in the semiconductor industry information about successful PFC emission reduction processes and technologies that the Partner Company considers nonconfidential.

- (i) Data item
  - Documentation describing applicable PFC reduction processes and technologies.
- (ii) Respondent activity
  - The Partner Companies will share information about successful PFC emission reduction processes and technologies by submitting this information to EPA.

## **5. THE INFORMATION COLLECTED--AGENCY ACTIVITIES, COLLECTION METHODOLOGY, AND INFORMATION MANAGEMENT**

### **5(a) Agency Activities**

The Partnership requires EPA to perform certain activities associated with the Company-specific Annual Report, the Industry-wide Annual Report, and the Information Sharing. Each of these three ongoing information collections, and the Agency's activities associated with them, are described in more detail below.

### **Memorandum of Understanding**

EPA developed an MOU in cooperation its industry partners and has signed agreements with the majority of the U.S. industry. EPA does not expect to take any further actions related to the partnership's MOU.

### **Company-specific Annual Reports**

EPA will perform the following activities with regard to the Company-specific annual report submitted by the Partner Company to the designated third party:

- Review Company-specific annual reports on the premises of the designated third party, on a blind basis.

## **Industry-wide Annual Reports**

EPA will perform the following activities with regard to the industry-wide annual report submitted by the designated third party to EPA:

- Receive and review the industry-wide annual report; and
- File and maintain copies of the report.

## **Information Sharing**

EPA will perform the following activities with respect to information sharing with the Partner Company and the public:

- Establish and maintain clearinghouse of technical information on successful strategies for reducing PFC emissions; and
- Provide public recognition of Partner Companies' achievements in reducing PFC emissions and for their public service in protecting the environment.

## **5(b) Collection Methodology and Management**

In collecting and analyzing the information associated with this ICR, EPA uses electronic equipment such as personal computers and applicable database software. EPA will ensure the accuracy and completeness of collected information by reviewing each Partner Company's submitted information. EPA will maintain files of MOUs and other reports. Public access to the overall annual emission estimate will be possible through EPA's partnership Internet web site ([www.epa.gov/semiconductor-pfc](http://www.epa.gov/semiconductor-pfc)), annual CCAP reporting, EPA's annual Inventory of U.S. Greenhouse Gas Emissions and Sinks, and informational materials EPA will prepare to publicize the successes of the Partnership.

## **5(c) Small Entity Flexibility**

EPA reviewed available company Web sites for Partner companies that were believed may be small entities. Upon completion of the review, EPA estimates none of its semiconductor industry Partners are small entities. Regardless, EPA has designed the program and reporting form to minimize respondent burden while obtaining sufficient and accurate information. In addition, the burden associated with the PFC Reduction/Climate Partnership for the Semiconductor Industry is inherently reduced since the initial agreement to participate is voluntary.

## **5(d) Collection Schedule**

EPA collects information in the MOU, which is completed and submitted by the Partner Company. EPA will receive the Partnership's emissions report from the designated third party on an annual basis. EPA may collect other program information on a periodic basis or as the information is submitted.

## 6. ESTIMATING THE BURDEN AND COST OF THE COLLECTION

### 6(a) Estimating Respondent Burden

Exhibit 1 presents the estimated annual respondent burden and costs for information collection activities associated with the PFC Reduction/Climate Partnership for the Semiconductor Industry. The exhibit includes the number of hours required to conduct the information collection activity and the cost associated with each requirement. In developing burden estimates for each information collection requirement in this ICR, EPA consulted with current Partner Companies. (See Section 3(c) of this ICR for information on the consultations.) As shown in Exhibit 1, EPA estimates a total annual respondent burden of approximately 11,426 hours. Assumptions used in calculating this estimate are described below.

### 6(b) Estimating Respondent Costs

#### Labor Costs

EPA estimates respondent labor costs by adding U.S. wages<sup>2</sup> to employers' costs for employee compensation<sup>3</sup> for the appropriate respondent categories and multiplying the total by 1.35 to adjust for an assumed 35 percent overhead rate. For the Partner Companies, EPA estimates average hourly labor rates of \$114.87 for legal staff, \$113.02 for engineering managers, \$64.15 for semiconductor production technicians, and \$67.03 for clerical staff. Table 1 summarizes EPA's estimated labor rates as explained above.

**Table 1:  
Average Hourly Respondent Labor Rates**

Type of Respondent	Legal	Engineering Managers	Technical (Semiconductor Production)	Clerical
Wages (hourly)	\$54.65	\$52.90	\$16.70	\$18.83
Employee Compensation	\$30.44	\$30.82	\$30.82	\$30.82

<sup>2</sup> U.S. Department of Labor, Bureau of Labor Statistics May 2007. <http://www.bls.gov/news.release/pdf/ocwage.pdf>

<sup>3</sup> U.S. Department of Labor, Bureau of Labor Statistics December 2007.

<http://www.bls.gov/news.release/pdf/ecec.pdf>

(hourly)				
<b>Total Hourly Labor Rate = sum of above x 1.35</b>	<b>\$114.87</b>	<b>\$113.02</b>	<b>\$64.15</b>	<b>\$67.03</b>

**Capital and Operation and Maintenance (O&M) Costs**

The Companies participating in the Partnership are not required to incur any notable capital costs under the Partnership (i.e., for analytical equipment used to develop PFC emissions factors). The Partner Companies' equipment suppliers normally characterize PFC emissions and provide this information as a standard business practice. In addition, emissions factors tables are available to the industry through the Intergovernmental Panel on Climate Change.

Companies participating in the Partnership may incur annual operation and maintenance (O&M) costs. Partner Companies may incur O&M costs by continuing to develop and operate gas tracking programs, operating and maintaining analytical equipment to allow for continued analysis of emissions, and submitting information to EPA (based on postage costs of \$3.00 per mailing). Partner Companies also may incur O&M costs associated with travel to meetings as a part of their sharing of information.

**6(c) Estimating Agency Burden and Cost**

Exhibit 2 presents the estimated Agency burden hours and costs for the information collection activities associated with this ICR. EPA estimates an average hourly labor cost (labor plus overhead) of \$71.34 for legal staff, \$66.72 for managerial staff, \$48.91 for technical staff, and \$19.65 for clerical staff. To derive these estimates, EPA used the "Hourly Salary Table 2007 - GS" from the Department of Personnel Management. For purposes of this ICR, EPA assigned staff the following government service levels:

- Legal Staff                                      GS-15, Step 1
- Managerial Staff                               GS-14, Step 4
- Technical Staff                                 GS-12, Step 5
- Clerical Staff                                   GS-5, Step 1.

To derive the loaded hourly estimates, EPA multiplied hourly rates by the standard government overhead factor of 1.6. As shown in Exhibit 2, EPA estimates that the annual Agency burden for all activities covered in this ICR is 218 hours at a total cost of \$12,696.



## **6(d) Estimating the Respondent Universe and Total Respondent Burden and Costs**

### **Respondent Universe**

EPA expects the current 21 Partner Companies to maintain their active participation for the three-year effective life of this ICR renewal. The following paragraphs discuss the information collections these Partner Companies will perform under the Partnership. Exhibit 1 calculates the annual burden and cost to Partner Companies in performing these collections.

### **Company-Specific Annual Report**

Each Partner Company agrees to prepare a Company-specific annual report to be submitted to the designated third party. The report will provide an estimate of the company's PFC emissions by gas for the previous calendar year. Most of EPA's current Partner Companies have participated and prepared annual reports since 1999. As shown in Exhibit 1, EPA estimates that Partner Companies will require 290.5 hours to prepare and submit the annual reports to the designated third party.

### **Industry-wide Annual Report**

The designated third party will be responsible for receiving and tracking the Company-specific annual reports and compiling them into an industry-wide annual report. The designated third party will create and update a confidential data depository containing the annual reports supplied by the Partner Companies. The designated third party will provide to EPA an industry-wide annual report. Based on the Company-specific annual reports, the designated third party will provide an aggregated, overall PFC emissions estimate.

In addition, the designated third party will make available to EPA emissions estimates prepared by the Partner Companies and the written explanation of the methodology used. This information also will be maintained on site by the designated third party and reviewed by EPA on the designated third party's premises. These activities are reflected in Exhibit 1.

### **Information Sharing**

The Companies participating in the Partnership agree to share with EPA information about successful PFC emission reduction processes and technologies that the Partner Companies consider nonconfidential, and will share such nonconfidential information with others in the semiconductor industry. Partner Companies may incur burden and costs for attending meetings (including travel and lodging costs), participating in teleconferences with EPA and industry, and other outreach efforts. EPA estimates the all 21 Partner Companies will share information each year. The Partners' expected activities are reflected in Exhibit 1.

## **6(e) Bottom Line Burden Hours and Costs**

### **Respondent Tally**

In Exhibit 1, EPA estimates the total annual respondent burden and cost for the PFC Emission Reduction Partnership to be approximately 11,426 hours and \$1,054,780. The bottom line respondent burden over the three-year period covered by this ICR is approximately 34,278 hours, at a total cost of approximately \$3,164,340. The total annual capital and O&M costs for the partnership are estimated to be \$116,319 per year.

### **Agency Tally**

As shown in Exhibit 2, the annual Agency burden and cost are estimated to be approximately 218 hours and \$12,696 per year. The bottom line Agency burden over the three-year period covered by this ICR is approximately 654 hours, at a total cost of approximately \$38,088.

### **Variations in the Annual Bottom Line**

EPA anticipates no significant variation in the annual respondent reporting and/or recordkeeping burden over the next three years.

## **6(f) Reasons for Change in Burden**

The number of burden hours has not changed from the previous ICR but the estimated annual burden cost increased to reflect updated labor compensation rates as provided by the U.S. Department of Labor. The number of Companies in the Partnership is expected to remain at 21. This ICR does not expect burden hours associated with the MOU activities.

## **6(g) Burden Statement**

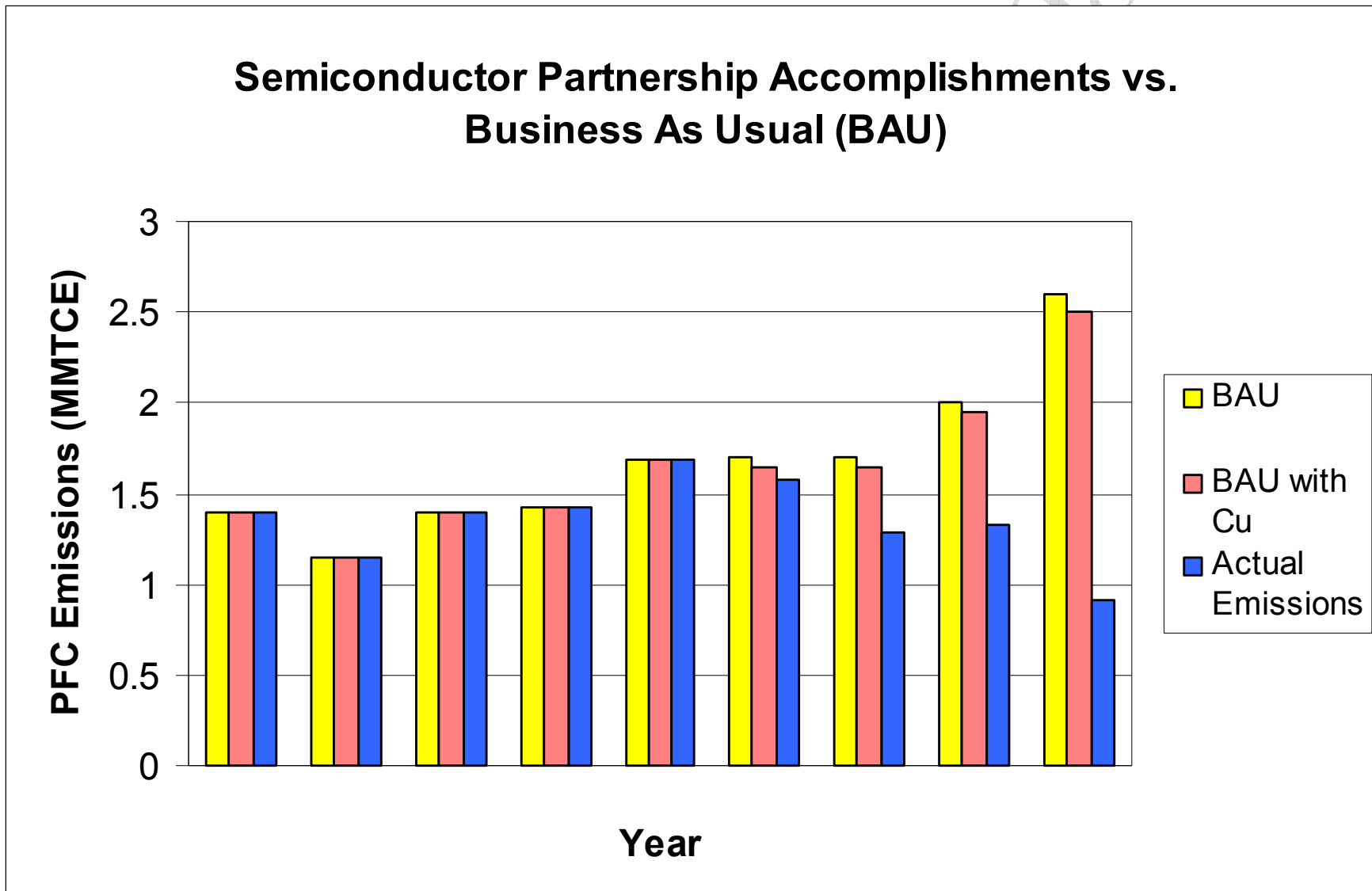
The annual public reporting burden for this collection of information is estimated to average 544 hours per Partner Company. There is no recordkeeping burden for Partners. The annual reporting burden is estimated to be about eight hours for the designated third party. The eight-hour estimate includes time for preparing and submitting the industry-wide annual report and making emissions data available to EPA. The annual recordkeeping burden to the designated third party is estimated to be roughly 46 hours. This burden includes time for updating and maintaining the data depository, receiving and entering Company-specific reports into the depository, and filing and maintaining copies of Company-specific annual reports. Burden means the total time, effort, or financial resources expended by persons to generate, maintain, retain, or disclose or provide information to or for a Federal agency. This includes the

time needed to review instructions; develop, acquire, install, and utilize technology and systems for the purposes of collecting, validating, and verifying information, processing and maintaining information, and disclosing and providing information; adjust the existing ways to comply with any previously applicable instructions and requirements; train personnel to be able to respond to a collection of information; search data sources; complete and review the collection of information; and transmit or otherwise disclose the information. An agency may not conduct or sponsor, and a person is not required to respond to, a collection of information unless it displays a currently valid OMB control number. The OMB control numbers for EPA's regulations are listed in 40 CFR part 9 and 48 CFR chapter 15.

To comment on the Agency's need for this information, the accuracy of the provided burden estimates, and any suggested methods for minimizing respondent burden, including the use of automated collection techniques, EPA has established a public docket for this ICR under Docket ID Number EPA-HQ-OAR-2004-0228, which is available for public viewing at the Air and Radiation Docket and Information Center in the EPA Docket Center (EPA/DC), EPA West, Room B102, 1301 Constitution Avenue, NW, Washington, DC. The EPA Docket Center Public Reading Room is open from 8:30 a.m. to 4:30 p.m., Monday through Friday, excluding legal holidays. The telephone number for the Reading Room is (202) 566-1744, and the telephone number for the Air and Radiation Docket and Information Center is (202) 566-1742.

An electronic version of the public docket is available at [www.regulations.gov](http://www.regulations.gov). This site can be used to submit or view public comments, access the index listing of the contents of the public docket, and to access those documents in the public docket that are available electronically. When in the system, select "search," then key in the Docket ID Number identified above. Also, you can send comments to the Office of Information and Regulatory Affairs, Office of Management and Budget, 725 17th Street, NW, Washington, DC 20503, Attention: Desk Office for EPA. Please include the EPA Docket ID No. EPA-HQ-OAR-2004-0228 in any correspondence.

Figure 1. U.S. Partner Companies' PFC emission with and without EPA Partnership.



DRAFT - 11 March 08